

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

TOSHIHISA NOZAWA, *et al.*

Serial No.: 10/585,408

Filed: July 7, 2006

For: SUBSTRATE PROCESSING APPARATUS

**Confirmation No. 2529**

Art Unit: 1792

Examiner: Keath T. CHEN

Atty. Dckt: 033082 M 335

**PETITION FOR A THREE-MONTH EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a Petition for an Extension of Time for a three month period. This Petition for Extension of Time is being concurrently filed with a Response and Request for Continued Examination (RCE).

Payment of the requisite fee is being made with a credit card using EFS-Web.

Respectfully submitted,  
SMITH, GAMBRELL & RUSSELL, LLP



Michael A. Makuch  
Reg. No. 32,263

Date: June 19, 2009

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